

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)
Koji Naniwada) Group Art Unit: **4177**
Application No. **10/565,222**)
Examiner: **Eric R. Hamill**
Filed: **January 20, 2005**)
For: MEMS TYPE RESONATOR, PROCESS FOR)
FABRICATING THE SAME AND)
COMMUNICATION UNIT)

MAIL STOP AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO JUNE 16, 2008 OFFICE ACTION

Dear Sir:

This Response is submitted in reply to the Office Action mailed June 16, 2008.
Applicant respectfully requests reconsideration of the application in view of the Amendment and
Remarks herein.